



Serial No. 10/040017

1756B

IN THE UNITED STATES  
PATENT AND TRADEMARK OFFICE

**PATENT APPLICATION**

Inventor(s): **Mischa Megens  
Pierre Wiltzius  
Shu Yang**

Case: **1-10-5**

Serial No.: **10/040017**

Filing Date: **January 4, 2002**

Examiner: **M. Angebrannt** Group Art Unit: **1756**

Title: **Fabricating Artificial Crystalline Structures**

**COMMISSIONER FOR PATENTS**

**P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450**

**SIR:**

**INFORMATION DISCLOSURE STATEMENT**  
**UNDER 37 CFR 1.97(c)(2)**

In accordance with 37 CFR 1.97(c)(2), the enclosed Information Disclosure Statement, with attached reference(s), is submitted for consideration in the above-identified application.

Please charge the amount of \$180.00 to **Lucent Technologies Deposit Account No. 12-2325** to cover the fee under 37 CFR 1.17(p). Duplicate copies of this letter are enclosed.

05/04/2004 SDENB0B1 00000024 122325 10040017  
01 FC:1806 180.00 DA

Respectfully,

*John F. McCabe*

**John F. McCabe, Attorney**  
Reg. No. **42854**  
**908-582-6866**

Date: April 29, 2004

**Docket Administrator (Room 3J-219)**  
**Lucent Technologies Inc.**  
**101 Crawfords Corner Road**  
**Holmdel, NJ 07733-3030**

Date of Deposit	<u>2/29/04</u>
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<b>INFORMATION DISCLOSURE STATEMENT</b>	Case Name.	M. Megens 1-10-5
	Serial No.	10/040017
	Applicant:	M. Megens, et al.
	Filing Date:	January 4, 2002
	Group:	1756

**U.S. PATENT DOCUMENTS**

*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date

**FOREIGN PATENT DOCUMENTS**

Document Number	Date	Country	Class	Subclass	Translation

**OTHER (including Author, Title, Date, Pertinent Pages, etc.)**

AA	Lee, K.Y., LaBianca, N., Rishton, S.A., Zolgharnain, S., Gelorme, J.D., Shaw, J., Chang, T.H.-P., <i>Micromachining Applications Of A High Resolution Ultrathick Photoresist</i> , J. Vac. Sci. Technol. B 13(6) Nov/Dec 1995, pp. 3012-3016.

\*\*\*References listed beyond AZ would list as AA-1, AB-2, AC-3 thru AZ-26.

\*\*\*Note First Page ONLY Header/Footer. Subsequent pages must ONLY have page # layout as header

<b>EXAMINER</b>	<b>DATE CONSIDERED</b>

\***Examiner:** Initial if reference considered, whether or not citation is in conformance with MPEP 609: Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant